



Response Under 37 CFR 1.116
Expedited Procedure
Examining Group 2171

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11/9/04
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: US Patent Application 09/934,817
Filed August 21, 2001
Title Optical Arrangement and Projection Illumination Equipment for
Microlithography with Passive Thermal Compensation
Applicant Wagner et al.
Art Unit 2171
Examiner Etienne (Steve) LeRoux
Telephone (703) 305-0620
Attorney Docket (Z) C98003 P US

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Technology Center 2100

Mail Stop Art Unit 2171 - Amendment with Extension Fees
Commissioner for Patents
PO Box 1450
Alexandria, VA. 22313-1450

Amendment After Final Action

Dear Examiner LeRoux:

This amendment responds to the Office Action mailed July 14, 2003.

Following is the set of the claims in this case.